

H112/AA

503.30414V16

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): KATO, et al.

Filed: April 19, 2000

For: VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

April 19, 2000

Sir:

Please amend the above-identified application, prior to examination thereof, as follows:

IN THE SPECIFICATION

Please amend the specification as follows:

Page 1, delete lines 1-8 in their entirety, and substitute therefor the following:

L -- This application is a Divisional application of application Serial No. 09/461,432, filed December 16, 1999, which is a Continuation application of application Serial No. 09/177,495, filed October 23, 1998, ^{new US Pat 6,012,235} which is a Continuation application of application Serial No. 09/061,062, filed April 16, 1998, ^{new US Pat 5,950,330} which is a Continuation application of application Serial No. 08/882,731, filed June 26, 1997, ^{new US Pat 5,784,799} which is a Divisional application of application Serial No. 08/593,870, ^{new US Pat 5,661,913} filed January 30, 1996, which is a Continuing application of application Serial No. 08/443,039, filed May 17, 1995, ^{new US Pat 5,553,396} which

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